

GRAU 2811 \$

ATTORNEY DOCKET NO. 07977/192001/US3444

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani et al. Art Unit: 2811
Serial No.: 08/958,568 Examiner: S. Hu
Filed : 10/28/97
Title : SEMICONDUCTOR DEVICE AND METHOD O
FABRICATING THE SAME

Assistant Commissioner for Patents
Washington, DC 20231

TRANSMITTAL LETTER AND PETITION FOR AUTOMATIC EXTENSION

Correspondence relating to this application is enclosed. The required fees are computed below. Please apply any charges not covered, or any credits, to Deposit Account No. 06-1050.

Total Claims	<u>49</u>	-	<u>20</u>	=	<u>29</u>	\$ <u>522</u>
Independent	<u>7</u>	-	<u>3</u>	=	<u>4</u>	\$ <u>312</u>

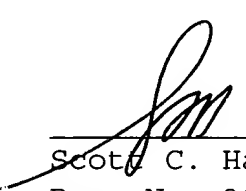
Applicant hereby petitions under 37 C.F.R.
1.136 for a three month extension of time. \$870

TOTAL FEE DUE: \$1704

A check for \$1704 is attached.

Respectfully submitted,

Date: 11/23/99



Scott C. Harris
Reg. No. 32,030

Fish & Richardson P.C.
4225 Executive Square, Suite 1400
La Jolla, CA 92037

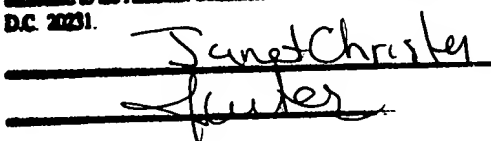
Telephone: 858/678-5070
Facsimile: 858/678-5099
10005689.doc

12/01/1999 TTRAW1 00000123 08958568

03 FC:117

870.00 DP

Date of Deposit 11-23-99
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.



Janet Christer

TC 20000123 08958568
11-23-99
FRI NOV 26 1999
COMM-FEDERAL

NOV 29 1999

PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ohtani, et al. Art Unit : 2811
Serial No: 08/958,568 Examiner : S. Hu
Filed : October 28, 1997
Title : SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING
THE SAME

Assistant Commissioner for Patents
Washington, D.C. 20231

#7 Reg Exp
Cinder A
Pender
12/1/99

AMENDMENT

Sir:

In response to the Official Action mailed June 10, 1999, in
the above-referenced application, kindly amend the application
as follows:

In The Title

Kindly change the title to --Semiconductor Device with
Improved Interconnections--.

In the Claims

Please cancel claims 1-6.

Please add the new claims as follows.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify that this correspondence is
being deposited with the United States Postal
Service as first class mail with sufficient
postage on the date indicated below and is
addressed to the Assistant Commissioner for
Patents, Washington, D.C. 20231.

12/01/1999 TTRAM1 00000123 08958568

01 FC:102 312.00 OP
02 FC:103 522.00 OP

11-23-99
Date of Deposit

Signature

Typed or Printed Name of Person Signing
Certificate